

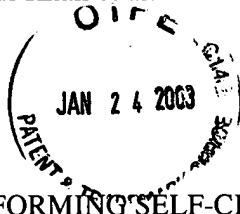
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Anisul Khan et al.

SERIAL NO.: 09/740,146

FILED: December 18, 2000

FOR: APPARATUS FOR PERFORMING SELF-CLEANING
METHOD OF FORMING DEEP TRENCHES IN
SILICON SUBSTRATES



§ GROUP ART UNIT: 1763

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§ EXAMINER: Unknown

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§ Attorney Docket No.: AM-3396.D1

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§ Date: January 24, 2003

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR § 1.97(c)**

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**Hon. Commissioner for Patents
Washington, DC 20231**

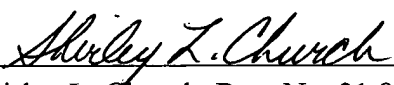
Sir:

In accordance with 37 CFR § 1.97(c), applicants hereby request consideration of this Supplemental Information Disclosure Statement. Applicants are providing herewith a copy of each document listed on the attached Form PTO-1449. This Supplemental Information Disclosure Statement is being submitted after the receipt of a first Office Action, but prior to the mailing of a final Office Action or Notice of Allowance in the subject application.

CERTIFICATE OF MAILING UNDER 37 CFR 1.10

I hereby certify that this paper is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as U.S. EXPRESS MAIL NO. NO. EU833879076US in an envelope addressed to the: Commissioner for Patents, Box DD, Washington, DC 20231.

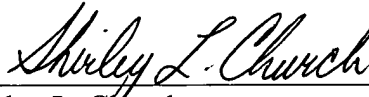
Date: January 24, 2003


Shirley L. Church, Reg. No. 31,858

Submitted herewith is a copy of the Search Report in corresponding EP Application No. 00120681.2-2203, dated September 27, 2002. Also submitted, are copies of all references listed on the Search Report, except for the ones which have already been listed in the Information Disclosure Statement filed for the subject patent application, on December 30, 2002.

If the Examiner has any questions, he is respectfully requested to contact the undersigned attorney at the telephone number set forth below.

Respectfully submitted,

A handwritten signature in cursive script, reading "Shirley L. Church", positioned above a horizontal line.

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